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**Document(s) Attached: Restriction Requirement  
Total Pages: 2 (including this page)**

In re application of:	Michael P. Belyansky et al.
Serial Number:	10/605,889
Filing Date:	November 4, 2003
Attorney:	Joseph P. Abate IBM Corporation Dept. 18G, B/300, Zip 482 2070 Route 52 Hopewell Junction, NY 12533-6531

**PLEASE DELIVER TO:**

**EXAMINER**            **Long Pham**  
**ART UNIT:**        **2814**  
**PHONE NO:**        571-272-1714  
**FAX NO:**            703-872-9306

**FROM:**            Daryl K. Neff  
                     4 Eugene Circle  
                     Lincoln Park, NJ 07035  
                     Phone 973-316-2612

**FIS920030286US1**

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P. 2

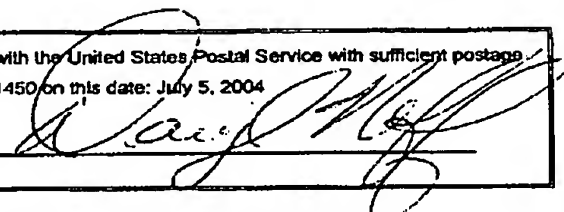
JUL 05 2004

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on this date: July 5, 2004

Name of Depositor:

Daryl K. Neff

Signature &amp; Date



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: <b>Michael P. Belyansky, et al.</b>	Date: <b>July 5, 2004</b>
Serial Number: <b>10/605,889</b>	Examiner: <b>Long Pham</b>
Filed: <b>November 4, 2003</b>	Group Art Unit: <b>2814</b>
Title: <b>OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH</b>	IBM Corporation D/18G, B/300, Zip 482 2070 Route 52 Hopewell Junction, NY 12533-6531

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

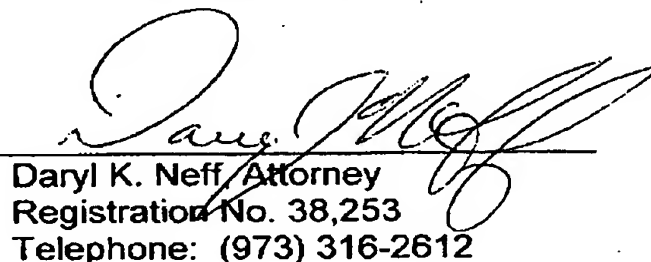
In response to the Restriction Requirement mailed June 7, 2004 restricting examination to Group I (Claims 1-20), drawn to a process of making a semiconductor device; and Group II (Claims 21-30) drawn to a semiconductor device, Applicants elect the claims of Group I (Claims 1-20) without traverse.

Prompt examination of this application is respectfully requested.

Respectfully submitted,

Michael P. Belyansky, et al.

By:



Daryl K. Neff, Attorney  
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